



DOCKET NO: VSEA 02-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daniel F. Downey et al.
Serial No: 09/996,446
Confirmation No: 2412
Filed: November 28, 2001
For: ATHERMAL ANNEALING WITH RAPID THERMAL
ANNEALING SYSTEM AND METHOD
Examiner: Jermele M. Hollington
Art Unit: 2829

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 26 day of March, 2004.


Cheryl Purcell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

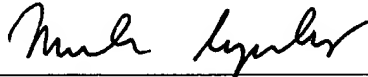
Petition for Extension of Time

A three-month extension of time to March 25, 2004 is requested for response to the Examiner's Office Action of September 25, 2003.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

03/30/2004 HLE333 00000066 500896 09996446
01 FC:1253 950.00 DA

Respectfully submitted,
Daniel F. Downey et al., Applicants

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